Amplitude Contrast Imaging in High-Resolution Transmission Electron Microscopy of Ferroelectric Superlattice Film

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To date, high-resolution electron microscopy has largely relied on using the phase of the exit wave function at the exit surface to form a high-resolution electron microscopic image. We have for the first time used chromatic aberration correction to implement a new imaging mode to achieve amplitude contrast imaging in high-resolution electron microscopy, allowing us to obtain directly interpretable high-resolution electron microscopic images with discrimination between light and heavy atomic columns. Using this imaging approach, we have successfully visualized the atomic structure in a BaTiO₃/CaTiO₃ superlattice with high spatial accuracy and discrimination between Ba and Ca columns, providing direct visualization of the Ca and Ba associated oxygen octahedral tilt that controls ferroelectric behavior in these superlattice structures. Furthermore, this approach offers new opportunities to unravel the structure in a wide range of materials, especially complex oxides with exotic behaviors based on specific structural arrangements.

Subject Areas: Materials Science, Strongly Correlated Materials

Interface engineering based on ABO₃ perovskite oxide heterostructures has led to new functional properties such as enhanced ferroelectricity [1–4], magnetoelectric coupling [5], spinstructural response [6], and piezoelectricity [7]. Multifunctionality has been achieved through the atomic-level control of the associated BO₆ octahedral distortion at interfaces. For example, enhanced piezoelectricity was observed in BaTiO₃/CaTiO₃ superlatice films [7,8], which was theoretically predicted based on suppression of oxygen octahedral rotations at the interfaces [9]. Understanding the underlying structural basis for these phenomena requires the precise determination of all atomic positions including oxygen at interfaces.

Transmission electron microscopy (TEM) is a powerful tool to visualize atomic structure in real space using high-resolution electron microscopy (HREM). In order to visualize the atomic structure of oxides at interfaces, such as CaTiO₃/BaTiO₃ ferroelectric superlatice structures, several imaging requirements must be satisfied as follows: 1) distinguish between atomic columns of different species to locate the interface at the atomic scale; 2) observe oxygen columns with a high signal to noise ratio; and 3) provide location spatial accuracy sufficient to resolve oxygen octahedral tilts. Conventional imaging modes generally do not meet all of these requirements.

In a scanning transmission electron microscope (STEM) equipped with a pre-specimen spherical aberration (C_s) corrector, high angle annular dark-field (HAADF) imaging mode can provide Z-contrast between atomic columns like Ba and Ca. However, for many materials, it is not possible to image all atomic columns at the same time using HAADF if the material consists of both light and heavy elements, such as oxides [10], and several different approaches may be required. For example, Borisevich *et al.* reported the suppression of octahedral tilts at the BiFeO₃-La_{0.7}Sr_{0.3}MnO₃ interface using a combination of STEM imaging modes [11]. This

required serial collection of images in different modes. It would be much better if the entire structure could be visualized in a single high quality image.

In a TEM with a post-specimen C_s corrector, Jia *et al.* showed that atomic columns of both heavy and light elements can be observed using an imaging mode termed negative sphericalaberration imaging (NCSI) [12–14]. This mode is achieved by exploiting C_s value to balance contrast and resolution and uses the phase of exit wave to form a HREM image. Although atomic positions are accurately determined using the NCSI imaging mode as shown in Pb(Zr,Ti)O₃ films [15,16], all atomic columns including oxygen appear white on a dark background, and as such one cannot readily distinguish between Ba and Ca columns.

In 1998, Foschepoth and Kohl theoretically predicted that amplitude contrast HREM (AC-HREM) can be used to obtain directly interpretable HREM images and distinguish light and heavy atoms in an aberration-corrected TEM [17]. Chen *et al* demonstrated this approach using a C_s-corrected TEM (without chromatic aberration (C_c) correction). The images they obtained show some features of amplitude contrast but are noisy and not satisfactory for direct structural interpretation [18]. Here, we exploit C_c correction that, together with correction of C_s and other higher order aberrations, allows one to experimentally implement practically useful AC-HREM. This imaging mode allows us obtaining a directly interpretable HREM image of all atomic columns including oxygen columns with spatial accuracy as well as distinguishing light Ca and heavy Ba atomic columns due to channeling contrast. Therefore, all three imaging requirements for the direct visualization of atomic structure at interfaces are satisfied. In this study, we used this new approach to directly observe the suppression of TiO₆ octahedral tilt at the interface of BaTiO₃ and CaTiO₃ in a ferroelectric BaTiO₃/CaTiO₃ superlattice [19].

As described by channeling theory [20], the phase of a propagating electron wave is a constant over the atomic column and spreads linearly with depth as schematically shown in Fig. 1. This means that phases of adjacent atomic columns overlap quickly when the sample becomes thick, and direct imaging of atomic columns is possible only for a very thin sample. In contrast, the amplitude of the exit wave is strongly peaked at the atomic column position and far less spread with depth as compared to phase. Therefore, the amplitude of the exit wave can be used to accurately determine atomic positions of the projected structure even when the sample is thick. More importantly, amplitude varies periodically with depth as shown in Fig. 1 and the oscillation period, characterized by an extinction distance, is inversely proportional to Z due to different electrostatic potential for different atoms [21]. Thus, imaging using amplitude of the exit wave can provide both good spatial accuracy and discrimination between atomic species based on atomic resolution channeling contrast. As an example, the amplitude and phase of the exit wave as a function of sample thickness for a CaTiO₃/BaTiO₃ interface is shown in Supplementary Materials S1. Since the amplitude of the exit wave is a function of sample thickness and atomic species within each column, ordered materials with light and heavy atomic columns are expected to show atomic resolution channeling contrast as a function of thickness when the imaging condition is favorable to obtain pronounced amplitude contrast and suppressed phase contrast.

Both conventional or C_s corrected HREM images are dominated by phase contrast as long as C_c is of significant magnitude. When both C_s and C_c are uncorrected in a conventional TEM, HREM images are taken under the Scherzer defocus to maximize phase contrast and resolution. [22] For a TEM with a C_s image corrector, correction of C_s towards zero improves resolution, but phase contrast decreases dramatically due to the limit of the uncorrected C_c damping envelope as shown in the Supplementary Materials S2. To balance resolution and phase

contrast, Jia *et al* introduced the NCSI method in which a negative C_s value (~ -10 to ~ -40 μ m) and a corresponding Lichte defocus are chosen to gain strong phase contrast with sufficient resolution to facilitate direct structural mapping [12,23,24]. Under typical NCSI imaging conditions, HREM images are dominated by phase contrast as shown in Supplementary Materials S3.

C_c correction allows correction of C_s towards zero to improve resolution without compromising contrast. Thus, when both C_s and C_c are corrected to small values, sub-Angstrom HREM using amplitude can be realized. As shown in Fig. 2, C_c correction extends the C_c damping envelope significantly towards high spatial frequencies. In this case, both the magnitude and the resolution for phase contrast and amplitude contrast increase without compromising contrast. Under perfect aberration correction, i.e. zero defocus Δf (or C₁), zero spherical aberration C_s (or C_3), and ignoring higher order aberrations ($C_5, C_7, ...$), the phase contrast of a thin object vanishes, and the remaining contrast is only amplitude contrast [25]. For practical situations, we cannot achieve such perfect imaging conditions, but the closer one gets to perfect aberration correction, the more dominant the amplitude contrast component becomes. For example, when C_c is uncorrected, HREM images obtained using nearly zero C_s and Δf contain amplitude contrast as shown in Fig. 3a (similar to Fig. 5a in the ref [18]), but they are noisy, exhibit more residual phase contrast, and do not provide sufficient resolution and contrast for direct structural interpretation. However, for a TEM with both Cs and Cc image corrector, under practically achievable amplitude contrast imaging (ACI) conditions (i.e. small but non-zero Cs and C_c values), simulated HREM images are strongly dominated by amplitude contrast as shown in Supplementary Materials S4. For example, the filled blue curves in Figs. 2a and 2b show phase contrast-transfer function (PCTF) and amplitude contrast-transfer function (ACTF) under an ACI imaging condition ($\Delta f = 1$ nm, $C_s = -3 \mu m$, and $C_c = 0.04$ mm). Under this ACI imaging condition, the ACTF has a value of near unity up to the information limit of the instrument, while the corresponding PCTF is suppressed to low values out to the information limit of the instrument. In essence, this condition approaches the perfect correction of aberration resulting in maximum amplitude contrast and minimum phase contrast [25]. This is demonstrated in Fig. 3b, which shows an AC-HREM image of Si [110] under an ACI imaging condition. It clearly shows that C_c correction allows obtaining AC-HREM with good resolution and good contrast. In addition to enhancing the amplitude contrast and suppressing the phase contrast, C_s and C_c correction also reduces image delocalization as shown in Fig. 2c. More details can be found in Supplementary Materials S5.

To illustrate the contribution of C_c correction to AC-HREM further, we use a CaTiO₃/BaTiO₃ interface as an example to compare the calculated phase and amplitude images of the exit wave with simulated HREM images as shown in Fig. 4. Fig. 4b and 4c show the calculated phase and amplitude of the exit wave for a 9 nm thick sample of a CaTiO₃/BaTiO₃ interface as schematically shown in Fig. 4a. Fig. 4d shows a simulated HREM image under an NCSI condition calculated using JEMS [26]. Calculated cross-correlation coefficients between the simulated image (d) with the phase (b) and amplitude (c) of exit wave are 0.641 and 0.585 respectively, indicating that HREM images obtained under medium C_s values exhibit significant phase contrast. Even when C_s is reduced to a lower value such as C_s = -3 μ m, the simulated image under an ACI condition under the corresponding Scherzer defocus. The measured cross-correlation coefficients between the simulated image (4f) with the phase (4b) and amplitude (4c)

of the exit wave are 0.417 and 0.865 respectively, indicating that HREM images obtained when both C_s and C_c are corrected are dominated by amplitude contrast.

AC-HREM provides several major advantages over phase contrast HREM as discussed by Lentzen [27]. First, an AC-HREM image has one-to-one correspondence to the projection of atomic columns with good spatial accuracy since the amplitude of exit wave is strongly peaked at each atomic column position. This one-to-one correspondence is similar to HAADF. Since image delocalization is nearly zero (see Fig. 2c), the image directly represents the object through the amplitude of exit wave. This enables one to obtain accurate projected positions for all atomic columns including defects. Second, AC-HREM provides direct structural mapping even for thicker samples due to the strong channeling effect. Simulations indicate direct structural mapping can be obtained for a sample up to 20 nm in thickness for a BaTiO₃/CaTiO₃ interface along [110] over a wide range of defocus. Third, an amplitude contrast HREM image contains channeling contrast for each atomic column [20]. For a thin sample, the amplitude contrast between different atomic columns is not strong, and a phase contrast HREM imaging mode like NCSI is more useful to enhance contrast. However, with increasing sample thickness, the amplitude intensity for each column becomes more pronounced, and an AC-HREM imaging mode like ACI can be more useful. By choosing a suitable sample thickness and defocus, one can reach an imaging condition that yields a contrast between different atomic columns based on the modulation of channeling contrast. For example, the extinction distance of Ba and Ca columns in BaTiO₃ and CaTiO₃ along the [110] zone axis in our ABO₃ ferroelectric heterostructure is about 8 nm and 14 nm, respectively, as estimated from simulated images. Thus, when the specimen thickness is around 8 nm to 10 nm, the exit waves of Ba and Ca columns are

expected to show opposite contrast, i.e. when the Ca columns are at maximum amplitude, the Ba columns are at minimum amplitude.

Fig. 5 shows the value of the AC-HREM imaging approach in correlating the structure of a (BaTiO₃)₄/(CaTiO₃)₄ ferroelectric superlattice to its properties [28]. In this HREM image, channeling contrast between Ba and Ca is clearly observed, in which atomic columns of CaO and BaO appear bright and dark, respectively. Oxygen and Ti columns appear as bright. The overall structure of alternating BaTiO₃ and CaTiO₃ is directly visualized using this imaging approach. More importantly, AC-HREM provides a direct and accurate measurement of the positions of oxygen columns that allows us to quantify TiO_6 tilt angles (along the [110] direction) as a function of distance from the interface (More details can be found in Supplementary Materials S6). The boxed columns marked 1,2,3 in Fig. 5a reveal the differences of TiO₆ octahedra orientation at the interface compared to that within the BaTiO₃ and CaTiO₃ sublayers. Oxygen octahedra in the BaTiO₃ sublayer do not tilt as indicated by flat TiO₂ planes (box 1) between adjacent BaO layers. In contrast, oxygen octahedra in the CaTiO₃ sublayer are tilted by ~ 9 degrees along the [110] direction as indicated by corrugated TiO₂ planes (box 2) between adjacent CaO layers. When a TiO_2 plane (box 3) is sandwiched between a BaO and a CaO layer at the interface, oxygen octahedral tilt is nearly suppressed (average tilt angle ~ 3 degrees). This interface effect is consistent with the predicted suppression of octahedral rotation (along the [001] direction) at the BaTiO₃/CaTiO₃ interface based on density functional theory (DFT) calculations [9].

Importantly, AC-HREM now allows us to reveal mixing between Ba and Ca at the interface (dashed box region of Fig. 5a) by a subtle change in the contrast of individual columns. This mixing can be measured quantitatively by comparing the intensity profile of the Ca/Ba plane

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illustrated in Fig. 5b with the JEMS calculated image shown in Fig. 5c. Simulation indicates that the mixing ratio at columns 1, 2, 3, 4, and 5 are Ca_{0.4}Ba_{0.6}, Ca_{0.5}Ba_{0.5}, Ca_{0.7}Ba_{0.3}, Ca_{0.7}Ba_{0.3}, and Ca_{0.6}Ba_{0.4} respectively. Since the simulation indicates a sample thickness of 9 nm corresponding to 16 cation atoms per column, these mixing ratios correspond to atom ratios Ca/Ba of 6/10, 8/8, 11/5, 10/6, for columns 1, 2, 3, 4, and 5 respectively. Thus, the distinguishable contrast between these columns suggests the sensitivity of the technique is approximately two atoms for this sample under these imaging conditions. This result is close to the prediction of single atom sensitivity suggested by Aert *et al* and Wang *et al* [20,29,30]. Detailed image simulation suggests a lower limit of detection of Ca occupancy around 0.3. In addition, the oxygen octahedral tilt angle right below the columns 1, 2, 3, 4, and 5 gradually increases with increasing mixing ratio of Ca/Ba. This indicates TiO₆ tilt is strongly localized both parallel and perpendicular to [001] direction, suggesting TiO₆ tilt is mainly determined by the nearest neighbor chemical environment. As shown in box 4 of Fig. 5, the presence of even one CaO column in the BaO layer is enough to cause a strong oxygen octahedral tilt.

In summary, amplitude contrast high-resolution electron microscopy provides directly interpretable atomic scale elemental and structural information in a single high-resolution electron microscopic image. Using this imaging approach, we have successfully visualized the A-site associated oxygen octahedral tilt in the ferroelectric BaTiO₃/CaTiO₃ superlattice. We found that the suppression of oxygen octahedral tilt by Ba atoms is localized at atomic scale.

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- [28] TEM sample preparation: The TEM sample was prepared using a focused-ion beam (FIB). The superlattice film was first coated with a thin layer of carbon using e-beam deposition to protect the film from ion beam damage. A thin section of the superlattice film on an SrTiO₃ substrate was lifted off and mounted on a FIB TEM grid. The thin section was thinned and polished with 30 kV Ga+ ions with a 50 pA beam current. The FIB prepared TEM sample was further polished with 500 eV Ar+ ions with 15 A of current to remove the damaged layer induced by the Ga+ ion beam.

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Figure Captions

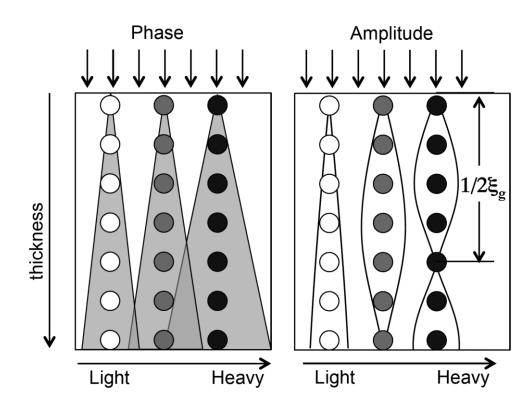
Fig. 1. Schematic representation of phase and amplitude of electron channeling through atomic columns with different atomic numbers. Phase expands linearly but amplitude oscillates around columns with depth. This figure demonstrates how imaging using the amplitude of exit wave can provide discrimination between light and heavy atomic columns.

Fig. 2. Contribution of C_c correction to achieve amplitude contrast HREM (AC-HREM). (a) Phase contrast transfer function (PCTF) for two imaging conditions: NCSI (green, $C_s = -40 \mu m$, $\Delta f = 8 nm$, $C_5 = 2 mm$, $C_c = 1 mm$) and AC-HREM (blue, $C_s = -3 \mu m$, $\Delta f = 1 nm$, $C_5 = 2 mm$, $C_c = 0.04 mm$). (b) Amplitude contrast transfer function (ACTF) for NCSI (green) and AC-HREM (blue) imaging conditions. (c) Image delocalization for the AC-HREM imaging condition. The vertical dashed line in each figure indicates the information limit of our instrument. The red curves in (a) and (b) indicate how C_c correction extends the C_c damping envelope from the dashed curve ($C_c = 1.0 mm$) to the solid curve ($C_c = 0.04 mm$) with high spatial frequencies, enabling AC-HREM (blue), while at the same time image delocalization is reduced (c).

Fig. 3. Amplitude contrast HREM image of Si [110] for a) uncorrected C_c ($C_c = 1.9$ mm, $C_s < 0.5 \mu$ m), b) corrected C_c ($C_c = 1$ mm, $C_c < 0.5 \mu$ m) demonstrating the effect of C_c correction in improving resolution and contrast. The images were acquired on adjacent areas of the sample using identical imaging conditions except of the value of C_c . c) and d) show intensity profiles at the lines indicated in a) and b). White dots surrounded by a dark ring in b) are the typical features caused by channeling contrast.

Fig. 4. Simulated images of the CaTiO₃/BaTiO₃ interface demonstrating that C_c correction enables AC-HREM. (a) Atomic arrangement along [110]. (b) Calculated exit wave phase image and (c) calculated exit wave amplitude image for a 9 nm thick sample. (d-g) Simulated HREM images. For an uncorrected C_c of 1.5mm (d, e), simulated images using (d) a medium C_s value (C_s = -40 μ m) and (e) a small C_s value (C_s = -3 μ m) show close correlation to phase image of the exit wave in (b). For a corrected C_c of 0.1 mm and a small C_s value of -3 μ m (f), the simulated image shows a close correlation to the amplitude image of the exit wave in (c). Adjusting defocus from (f) Δ f = 3 nm to (g) Δ f = 1 nm improves the amplitude contrast and reduces image delocalization further. The arrows indicate atomic columns with Ca_{0.5}Ba_{0.5}. C₅ = 2 mm in all simulated images. Simulation software: JEMS, multislice method.

Fig. 5. Experimental HREM image demonstrating AC-HREM for a CaTiO₃/BaTiO₃ superlattice film. (a) HREM image of a CaTiO₃/BaTiO₃ superlattice along [110] under an AC-HREM imaging condition ($C_s = 3 \mu m$, $\Delta f = -2 nm$, $C_5 = -2 mm$, $C_c = 1 \mu m$, as measured using the Zemlin Tableau method using an amorphous carbon film). Atom columns of CaO, Ti, and O in this image appear as bright dots while atom columns of BaO appear dark. The TiO₂ planes are flat when between two BaO layers (box 1) and corrugated when between two CaO layers (box 2). The presence of BaO on one side of a TiO₂ plane results in a suppression of oxygen octahedral rotation (box 3). At the interface, the presence of even *one* CaO column in the BaO layer is enough to cause a strong oxygen octahedral tilt (box 4). (b) Magnified image from the dashed box (box 5) in (a) showing the atomic-resolution channeling contrast for CaO/BaO columns. (c) Simulated image indicates the atomic-resolution channeling contrast is sensitive to Ca/Ba occupancy ratio. Columns 1, 2, 3, 4, 5 for the simulated structure are Ca_{0.4}Ba_{0.6}, Ca_{0.5}Ba_{0.5}, Ca_{0.7}Ba_{0.3}, Ca_{0.7}Ba_{0.3}, and Ca_{0.6}Ba_{0.4} respectively. The intensity profile from experimental image in (b) matches well with the simulated intensity profile. Note that the brighter CaO/BaO column in the dashed box in (b), the larger tilt angle of TiO₆ octahedral underneath each CaO/BaO column.





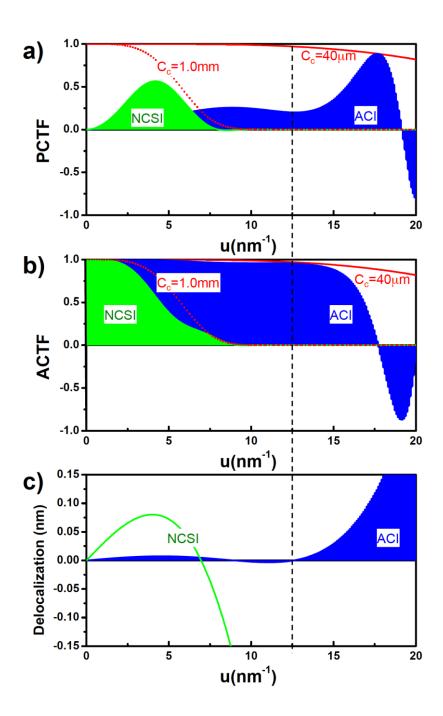


Fig. 2

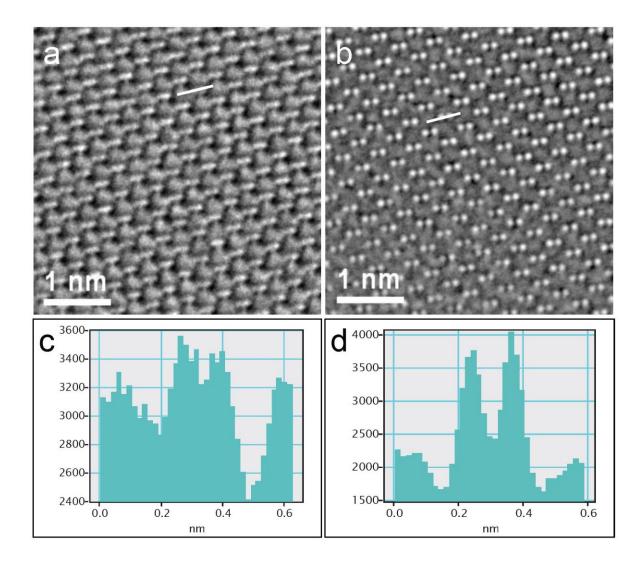


Fig. 3

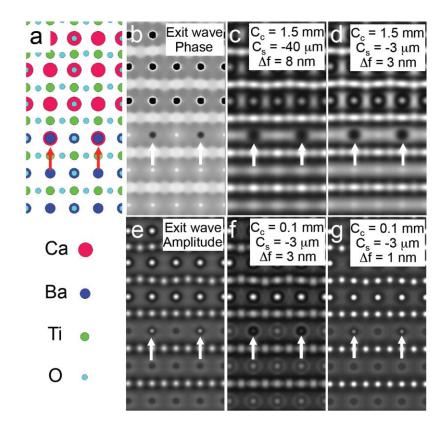


Fig. 4

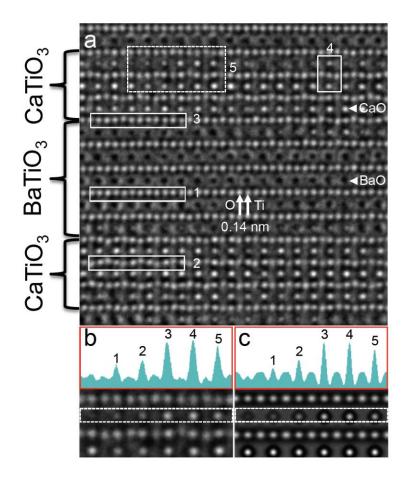


Fig. 5